

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/747,690	KIM, KI DUK	
Examiner	Art Unit	
RICARDO L. OSORIO	2629	

SEARCHED					
Class	Subclass	Date	Examiner		
345	98,99,100 102 87-89	9/28/07	RLO		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST	9/28/07	RLO		